

<b>Notice of References Cited</b>	Application/Control No.	Applicant(s)/Patent Under Reexamination	
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	Examiner	Art Unit	Page 1 of 1
Erik Kielin	2813		

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K	US-			
L	US-			
M	US-			

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**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	Van Zant, Microchip Fabrication, 4th ed. McGraw-Hill: New York, 2000, pp. 72-74.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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